

contact spring is secured by means of a screw. The contact element 37 extends into the region of the undercut 35 of the seal 32 and is provided with a contact cusp or a rounded contact end 39. The rounded contact end 39 serves for the electrical contact of a rim region of a surface 40 of the wafer 31 that faces the process container 2. The electrically contacted rim region of the surface 40 of the wafer 31 is disposed radially beyond a contact region between the surface 40 and the seal 32, and is thus insulated relative to the interior of the process container 2.

## **REMARKS**

In light of the foregoing amendment, Applicant respectfully submits that the present application now stands in condition for allowance. Action to this end is courteously solicited.

Respectfully submitted,

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## Version with Markings to Show Changes Made

## IN THE SPECIFICATION:

Please replace the entire paragraph on page 12, beginning on line 5 and continuing through line 14, with the following:

On the outer side of the container wall 9 a contact element 37 in the form of a contact spring is secured by means of a screw. The contact element 37 extends into the region of the undercut 35 of the seal 32 and is provided with [\_\_\_\_\_\_\_ cusp on??] a contact cusp or a rounded contact end 39. The rounded contact end 39 serves for the electrical contact of a rim region of a surface 40 of the wafer 31 that faces the process container 2. The electrically contacted rim region of the surface 40 of the wafer 31 is disposed radially beyond a contact region between the surface 40 and the seal 32, and is thus insulated relative to the interior of the process container 2.